

Notice of References Cited	Application/Control No. 10/736,983		Applicant(s)/Patent Under Reexamination TOMOYASU ET AL.	
	Examiner OLVIN LOPEZ		Art Unit 2121	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,514,667	02-2003	Angelopoulos et al.	430/271.1
*	B	US-7,337,019	02-2008	Reiss et al.	700/21
*	C	US-6,665,575	12-2003	Betawar et al.	700/121
*	D	US-7,328,418	02-2008	Yamashita et al.	716/10
*	E	US-6,864,041	03-2005	Brown et al.	430/316
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Natzle et al, "Trimming of Hard Masks by COR for gate length control and fr embedded logic", pages 1-5, may 2004.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.